

Walter E Henderson

List of Publications by Year in descending order

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31
papers

407
citations

840776

11
h-index

752698

20
g-index

31
all docs

31
docs citations

31
times ranked

568
citing authors

| # | ARTICLE | IF | CITATIONS |
|----|---|------|-----------|
| 1 | InN: A material with photovoltaic promise and challenges. Journal of Crystal Growth, 2006, 288, 218-224. | 1.5 | 82 |
| 2 | Transient atomic behavior and surface kinetics of GaN. Journal of Applied Physics, 2009, 106, . | 2.5 | 41 |
| 3 | III-nitride integration on ferroelectric materials of lithium niobate by molecular beam epitaxy. Applied Physics Letters, 2005, 87, 171107. | 3.3 | 34 |
| 4 | Molecular beam epitaxy of complex metal-oxides: Where have we come, where are we going, and how are we going to get there?. Journal of Vacuum Science & Technology an Official Journal of the American Vacuum Society B, Microelectronics Processing and Phenomena, 2005, 23, 1272. | 1.6 | 32 |
| 5 | Spatially resolved 3D metabolomic profiling in tissues. Science Advances, 2021, 7, . | 10.3 | 29 |
| 6 | Extremely high hole concentrations in c-plane GaN. Physica Status Solidi C: Current Topics in Solid State Physics, 2009, 6, S788. | 0.8 | 27 |
| 7 | Strain relaxation via formation of cracks in compositionally modulated two-dimensional semiconductor alloys. Npj 2D Materials and Applications, 2018, 2, . | 7.9 | 23 |
| 8 | Halide based MBE of crystalline metals and oxides. Physica Status Solidi C: Current Topics in Solid State Physics, 2012, 9, 155-160. | 0.8 | 20 |
| 9 | Mg doped GaN using a valved, thermally energetic source: enhanced incorporation, and control. Journal of Crystal Growth, 2005, 279, 26-30. | 1.5 | 18 |
| 10 | A versatile metal-halide vapor chemistry for the epitaxial growth of metallic, insulating and semiconducting films. Journal of Crystal Growth, 2011, 324, 134-141. | 1.5 | 17 |
| 11 | Growth of InN on Ge substrate by molecular beam epitaxy. Journal of Crystal Growth, 2005, 279, 311-315. | 1.5 | 14 |
| 12 | Complementary oxide memristor technology facilitating both inhibitory and excitatory synapses for potential neuromorphic computing applications. , 2009, , . | | 12 |
| 13 | III-Nitride Growth on Lithium Niobate: A New Substrate Material for Polarity Engineering in III-Nitride Heteroepitaxy. Materials Research Society Symposia Proceedings, 2002, 743, L1.4.1. | 0.1 | 11 |
| 14 | Influence of growth conditions and surface reaction byproducts on GaN grown via metal organic molecular beam epitaxy: Toward an understanding of surface reaction chemistry. Journal of Electronic Materials, 2006, 35, 562-567. | 2.2 | 7 |
| 15 | Growth and characterization of Al _x Ga _{1-x} N via NH ₃ -based metal-organic molecular beam epitaxy. Journal of Crystal Growth, 2009, 311, 1328-1332. | 1.5 | 6 |
| 16 | A mechanistic study of the interaction of water-soluble borate glass with apatite-bound heterocyclic nitrogen-containing bisphosphonates. Acta Biomaterialia, 2016, 31, 339-347. | 8.3 | 5 |
| 17 | Mg Doped GaN Using a Valved, Thermally Energetic Source: Enhanced Incorporation, Control and Quantitative Optimization. Materials Research Society Symposia Proceedings, 2003, 798, 719. | 0.1 | 4 |
| 18 | Mixed alkyl exchange and exploitable surface interactions in InGa _N by NH ₃ -based metal organic molecular beam epitaxy. Journal of Crystal Growth, 2008, 310, 5297-5302. | 1.5 | 4 |

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|----|---|-----|-----------|
| 19 | Fractal Electrode Formation in Metal-Insulator Composites Near the Percolation Threshold. IEEE Nanotechnology Magazine, 2013, 12, 725-733. | 2.0 | 4 |
| 20 | ALD TiO ₂ as a top-gate dielectric and passivation layer for InGaZnO ₁₁₅ ISFETs. Semiconductor Science and Technology, 2017, 32, 114004. | 2.0 | 4 |
| 21 | Molecular Beam Epitaxy of Lithium Niobate Multifunctional Materials Using a Chloride Refractory Metal Chemistry. ECS Transactions, 2006, 2, 103-114. | 0.5 | 3 |
| 22 | Growth kinetics of Al _x Ga _{1-x} N grown via ammonia-based metal-organic molecular beam epitaxy. Journal of Crystal Growth, 2010, 312, 209-212. | 1.5 | 3 |
| 23 | Molecular Beam Epitaxial Growth of AlN/GaN Multiple Quantum Wells. Materials Research Society Symposia Proceedings, 2002, 743, L6.2.1. | 0.1 | 2 |
| 24 | In situ Auger probe enabling epitaxy composition control of alloys by elemental surface analysis. Journal of Vacuum Science and Technology B: Nanotechnology and Microelectronics, 2013, 31, 03C126. | 1.2 | 2 |
| 25 | An investigation of the effects of radiation exposure on stability constraints in epitaxial SiGe strained layers. Solid-State Electronics, 2006, 50, 1194-1200. | 1.4 | 1 |
| 26 | Investigation into the use of molecular hydrogen on the growth of gallium nitride via metal-organic molecular beam epitaxy. Physica Status Solidi C: Current Topics in Solid State Physics, 2008, 5, 1723-1725. | 0.8 | 1 |
| 27 | Impact of Microstructure on Dielectric Nanocomposites With High- <i>k</i> Interfacial Layers. IEEE Nanotechnology Magazine, 2015, 14, 717-725. | 2.0 | 1 |
| 28 | Reclamation of a molecular beam epitaxy system and conversion for oxide epitaxy. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 2008, 26, 1501-1506. | 2.1 | 0 |
| 29 | High-Temperature Growth of GaN and Al _x Ga _{1-x} N via Ammonia-Based Metalorganic Molecular-Beam Epitaxy. Journal of Electronic Materials, 2010, 39, 473-477. | 2.2 | 0 |
| 30 | Using a university characterization facility to educate the public about microscopes: light microscopes to SEM. , 2015, , . | | 0 |
| 31 | Characterization and Simulation of Permittivity Enhancements of Si ₃ N ₄ /SiO ₂ /Si ₃ N ₄ /SiO ₂ /Si ₃ N ₄ /SiO ₂ Nanolaminate Layers. , 2018, , . | | 0 |